

Receipt date: 08/30/2010

Docket No. F-8601

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1795**

DO NOT ENTER: /WL/ (09/10/2010)

**RECEIVED
CENTRAL FAX CENTER
AUG 30 2010**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideo YOSHIDA, et al.
Serial No. : 10/526,205
Filed : March 1, 2005
For : ANODIC OXIDATION METHOD, TITANIUM OXIDE
FILM MANUFACTURING METHOD AND
CATALYST CARRYING METHOD
Group Art Unit : 1795
Examiner : William T. Leader
Confirmation No. : 4976
Customer No. : 000028107

Certificate of Facsimile Transmission Under 37 CFR 1.8

I hereby certify that this correspondence is being transmitted in accordance with 37 CFR §1.6(d) to the United States Patent Office addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on August 30, 2010 to facsimile no. (571) 273-8300 .
TOTAL NUMBER OF PAGES TRANSMITTED: 14
PLEASE TRANSMIT ACKNOWLEDGMENT TO 212 953 7733

C. Bruce Hamburg
(Name)


(Signature)

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Sir:

In response to the final Office Action of April 29, 2010, entry of the present amendment effecting claim amendments to place the application in

F8601 andl exp to 2010-04-29 for (PC83).wpd